Docket Number (Optional)	Application Number		
D2337 D2	Unassigned		
Applicant(s)			
Fwu-Iuan Hshieh et al.			
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INFO			Applicant(s) Fwu-Iuan Hshieh e	et al.			
			Filing Date Filed Herewith		Group Art Unit 2818		
			U.S. PATENT DOCUMENTS			-	
REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	1	
1	6,144,065	11/7/2000	Kinzer	257	327		
2	6,025,237	2/15/2000	Choi	438	301	<u> </u>	
3	5,072,266	12/10/1991	Bulucea et al.	357	23.4		
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1	WO 94/03922	02/17/1994	PCT	H01L 21	265	1	
2	61190981	08/25/1986	JP	H01L 29	78		1
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EXAMINER Chroty Kovacek DATE CONSIDERED 3/21/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.